



**APPLICATION DATA SHEET**

Electronic Version v14

Stylesheet Version v14.0

<b>Title of Invention</b>	METHOD OF DOUBLE-SIDED ETCHING		
Application Type :		regular, utility	
Attorney Docket Number :		TMIP0003USA	
Correspondence address:			
Customer Number:	027765		
Priority Data:			
Doc.No: 093122940; Country -TW ; Date: 2004-07-30 us-priority-claimed			
Inventor Information:			
<u>Inventor 1:</u>			
<b>Applicant Authority Type:</b>	Inventor		
<b>Citizenship:</b>	TW		
<b>Given Name:</b>	Chen-Hsiung		
<b>Family Name:</b>	Yang		
<b>Residence:</b>			
<b>City of Residence:</b>	Taipei Hsien		
<b>Country of Residence:</b>	TW		
<b>Address-1 of Mailing Address:</b>	2F, No. 1, Lane 61, Fenziwei St., Sanchung City		
<b>Address-2 of Mailing Address:</b>			
<b>City of Mailing Address:</b>	Taipei Hsien		
<b>State of Mailing Address:</b>			
<b>Postal Code of Mailing Address:</b>			
<b>Country of Mailing Address:</b>	TW		
<b>Phone:</b>			
<b>Fax:</b>			
<b>E-mail:</b>			
Attorney Information:			
practitioner(s) at Customer Number:			
027765			

as my attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.